What is claimed is:

- 1. A method of fabricating a display device, wherein the thickness of a first levelling film formed above a wiring is thinner than that of a second levelling film formed on the first levelling film.
- 2. A method of fabricating a display device, wherein the thickness of a first levelling film formed above a wiring is thinner than that of a second levelling film formed on the first levelling film, and wherein the thickness of the first levelling film is $0.1 \, \mu \text{m}$ or more and less than $1.5 \, \mu \text{m}$.
- 3. A method of fabricating a display device, wherein the thickness of a first levelling film formed above a wiring is thinner than that of a second levelling film formed on the first levelling film, and wherein the thickness of the second levelling film is from $0.1 \, \mu m$ to $2.9 \, \mu m$ inclusive.
- 4. A method of fabricating a display device, wherein the thickness of a first levelling film formed above a wiring is thinner than that of a second levelling film formed on the first levelling film, and wherein the total thickness of the first levelling film and the second levelling film is from $0.2 \, \mu \text{m}$ to $3.0 \, \mu \text{m}$ inclusive.
- 5. A method of fabricating a display device, wherein the thickness of a first levelling film formed above a wiring is thinner than that of a second levelling film formed on the first levelling film, and wherein the first levelling film and the second levelling film are insulating films formed by spin coating.

- 6. A method of fabricating a display device, wherein the thickness of a first levelling film formed above a wiring is thinner than that of a second levelling film formed on the first levelling film, and wherein the first levelling film and the second levelling film are made of any of a polyimide resin, an acrylic resin, a resin containing a siloxane structure, and an inorganic SOG material.
- 7. A method of fabricating a display device, wherein the thickness of a first levelling film formed above a wiring is thinner than that of a second levelling film formed on the first levelling film, and wherein the first levelling film and the second levelling film are made of the same material.

